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Dkt. 2271/71521

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

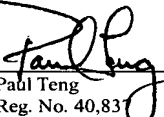
Application of: Takuro SEKIYA

Serial No. : 10/758,398

Date Filed : January 15, 2004

For : SOLUTION JET TYPE FABRICATION APPARATUS, METHOD,  
SOLUTION CONTAINING FINE PARTICLES, WIRING PATTERN  
SUBSTRATE, DEVICE SUBSTRATE

I hereby certify that this correspondence is being deposited this date with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
Paul Teng  
Reg. No. 40,837

August 31, 2004  
Date

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Pursuant to the applicant's duty of disclosure, the information listed in the attached Form PTO-1449 is brought to the attention of the Examiner. Applicant hereby submits this Information Disclosure Statement to supplement the Information Disclosure Statement Applicant filed with the United States Patent and Trademark Office on August 23, 2004 ("August 23, 2004 Information Disclosure Statement").

The reference (Peng et al.) identified on the annexed Form PTO-1449 was also cited in the Form PTO-1449 attached to the August 23, 2004 Information Disclosure Statement. However, a copy of the Peng reference was not enclosed with the August 23, 2004 Information Disclosure Statement.

This Information Disclosure Statement is submitted along with a copy of the Peng reference. It is respectfully requested that the Peng reference cited in annexed Form PTO-1449 be considered by the Examiner in connection with the above-identified patent application, and that such art be made of record in said application.

The citation of the listed items is not a representation that they constitute a complete or exhaustive listing of the relevant art or that these items are prior art. The items listed are submitted in good faith, but are not intended to substitute for the Examiner's search. It is hoped, however, that in addition to apprising the Examiner of the particular items, they will assist in identifying fields of search and in making as full and complete a search as possible.

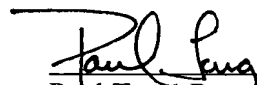
The filing of this Information Disclosure Statement is not an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

This Information Disclosure is submitted pursuant to 37 C.F.R. §1.97(b)(3). To the best of Applicant's knowledge, a first Office Action on the merits has not been issued in this application.

Alternatively, in the event that a first Office Action has been mailed but has not yet been received by Applicant or connected with the application file in the undersigned attorneys' office, Applicant hereby requests, pursuant to 37 C.F.R. §1.97(c)(2), consideration of this Information Disclosure Statement, and authorization is hereby given to charge to Deposit Account No. 03-3125 ONE HUNDRED AND EIGHTY DOLLARS (\$180.00), which is the amount of the fee under 37 C.F.R. §1.17(p) for filing an Information Disclosure Statement pursuant to 37 C.F.R. §1.97(c)(2).

No fees are believed to be required for this Information Disclosure Statement. However, the Office is hereby authorized to charge any fees which may be required for consideration of this Information Disclosure Statement and to credit any overpayment to our Deposit Account No. 03-3125.

Respectfully submitted,

  
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Form PTO-1400						U.S. Department of Commerce Patent and Trademark Office						Atty. Docket No. <b>2271/71521</b>				Serial No. <b>10/758,398</b>			
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)												Applicant: <b>Takuro SEKIYA</b>							
												Filing Date: <b>January 15, 2004</b>						Group Art Unit:	
U.S. PATENT DOCUMENTS																			
Examiner Initial		Document Number						Date		Name				Class		Subclass		Filing Date if Appropriate	
FOREIGN PATENT DOCUMENTS																			
		Document Number						Date		Country				Class		Subclass		Translation	
																		Yes No	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)																			
		Xiaogang Peng et al. (1997), "Epitaxial Growth of Highly Luminescent CdSe/CdS Core/Shell Nanocrystals with Photostability and Electronic Accessibility", J. Am. Chem. Soc., 119, pgs 7019-7029																	
EXAMINER												DATE CONSIDERED							
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.																			